Electronic Acknowledgement Receipt					
EFS ID:	2110040				
Application Number:	10812409				
International Application Number:					
Confirmation Number:	1261				
Title of Invention:	System and method for performing sputter etching using independent ion and electron sources and a substrate biased with an a-symmetric bi-polar DC pulse signal				
First Named Inventor/Applicant Name:	David Alan Baldwin				
Correspondence Address:	MORGAN, LEWIS & BOCKIUS LLP - 1701 Market Street - Philadelphia PA 19103-2921 US 2159635055 -				
Filer:	Daniel H. Golub				
Filer Authorized By:					
Attorney Docket Number:	53757-5013				
Receipt Date:	22-AUG-2007				
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Application Type:	Utility under 35 USC 111(a)				
Payment information:					

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File Listing:

			/Message Digest	Part /.zip	Pages (if appl.)				
1		Response20070822.pdf	116926	yes	2				
	rtesponsezoo706zz.pui	96fa098e338731d23e39f76df49990649 dc56026	ycs						
	Multipart Description/PDF files in .zip description								
	Document Description		Start	End					
	Amendment - After Non-Final Rejection		1	1					
	Applicant Arguments/Remarks Made in an Amendment		2	2					
Warnings:									
Information:									
2 Terminal Disclaimer Filed	TerminalDisclaimer1.pdf	349288	no	2					
		84fce438cdfc51ef9fa1c8928210c09cea dcc4a4							
Warnings:									
Information:				-					
3 Terminal Disclaimer Filed	TerminalDisclaimer2.pdf	349281	no	2					
		e71fa0d3785c92df4fe0f6e80549cdee0f 2beb81							
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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.